

Docket No.: 1248-0673P  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

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In re Patent Application of:  
Yutaka TAKAFUJI et al.

Application No.: 10/668,186

Confirmation No.: 4125

Filed: September 24, 2003

Art Unit: 2813

For: SINGLE-CRYSTAL SILICON SUBSTRATE,  
SOI SUBSTRATE, SEMICONDUCTOR  
DEVICE, DISPLAY DEVICE, AND  
MANUFACTURING METHOD OF  
SEMICONDUCTOR DEVICE

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Examiner: L. M. Schillinger

**AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION**

MS Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**INTRODUCTORY COMMENTS**

This Amendment represents a duplicate of amendments filed December 5, 2006. This Amendment is submitted because a New Office Action has not been sent as indicated in the May 10, 2007 Statement of Substance of the Interview.

In response to the Office Action dated April 16, 2007, please amend the above-identified U.S. patent application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 15 of this paper.